

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/730,967	CHAFFIN, JOHN HARVIE	
Examiner Archene Turner		Art Unit 1775	Page 1 of 1	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	P					
	Q					
	R					
	S					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Gruen et al "Fabrication and Characterization of Nano-Crystalline Diamond Films" presented at 40 <sup>th</sup> National Symposium 11/15-19, 1993
	V	Chase "Meeting Materials" in THE 2002 DOE Lab research Manual
	W	Popovici et al "(Smooth diamond films grown by hot filament chemical vapor deposition on positively based silicon substrates)" J. Mater. Res Vol 10, No. 8, 8/1995
	X	Kange et al "Morphology variation of diamond with increasing pressure up to 400 torr during deposition using hot filament CVD" Thin Solid Films 398-399, 2001, 175-179

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.